

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/591,505	HIRMER ET AL.	
Examiner		Art Unit		Page 1 of 1
Monique R. Jackson		1787		

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*	C	US-2003/0128496	07-2003	Allen et al.	361/306.3
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	M	US-			

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**NON-PATENT DOCUMENTS**

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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.